



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 09/902,277  
Filing Date ..... July 9, 2001  
Inventor..... Gurtej S. Sandhu et al.  
Assignee..... Micron Technology, Inc.  
Group Art Unit..... 2813  
Examiner ..... Schillinger, Laura M.  
Attorney's Docket No. .... MI22-1780  
Title: Method of Forming a Thin Film Transistor

**RESPONSE TO OCTOBER 21, 2003 FINAL ACTION ACCOMPANYING RCE FILING**

To: Mail Stop RCE  
Commissioner for Patents  
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**AMENDMENTS**

**Introductory Comments**

In reply to the Final Office Action of October 21, 2003, applicant amends and remarks as follows.

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